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# Resistive switching effects depending on Ni content in Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> nanoparticle devices†

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We synthesized Ni<sub>x</sub>Pt<sub>(1-x)</sub> nanoparticles with *x* ranging from 1 to 0.7. The particle size increases with the increasing Ni content. The *I*-*V* characteristics of Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> nanoparticles/Nb-0.7 wt%-doped SrTiO<sub>3</sub> are investigated. The resistive switching effects of Ni<sub>x</sub>Pt<sub>(1-x)</sub> nanoparticles at 300 K are observed, which are more pronounced than those of pure Ni. Remarkably, the *R*<sub>on</sub>/*R*<sub>off</sub> ratio increases with increasing Ni. Moreover, the RS effect remains after 50 cycles, presenting good endurance properties. With the samples annealed under different atmospheres, the concentration of oxygen vacancies varies inside the switching layer. The migration of oxygen vacancies is responsible for the RS effect.

## Introduction

In recent years, the resistive switching (RS) phenomenon was found in binary and multinary transition metal oxide films. It has attracted considerable attention due to its properties such as simple structure, high storage density, small device size, high reading and writing speed, low programming voltages, good stability, *etc.*,<sup>1,2</sup> showing potential application for next generation nonvolatile (NV) memory. A simple sandwich-like metal/insulator/metal (MIM) hetero-structure is the general configuration for applications in resistive random access memory (RRAM), which can be switched between the high resistance state (HRS) and the low resistance state (LRS) under an electric field.<sup>3,4</sup>

In general, a big bias voltage is required to activate the insulator and make it conductive. This main reason is attributed to two aspects,<sup>5,6</sup> (1) by applying a larger bias voltage to both ends of the electrode, the electron migration created more high density defects, (2) the oxygen vacancies form conductive channels at defects in order to reduce the resistance of the cells. According to the electric polarity, the RS effect can be divided into two types: unipolar (nonpolar), such as binary metal oxides<sup>7</sup> and bipolar, such as complex perovskite oxides.<sup>8</sup> For unipolar resistive switching, the effect relies heavily on the amplitude of the applied bias voltage; however, for unipolar resistive switching, this effect depends on the polarity of the applied bias voltage.<sup>9-11</sup> Up to now, the details of the switching mechanism are still controversial and more investigations are

still required.<sup>12</sup> A variety of models have been put forward to explain this mechanism, the following ones are generally accepted, including filament formation rupture model,<sup>13</sup> space charge limited conduction (SCLC),<sup>14</sup> Schottky barrier model<sup>15</sup> and metal insulator transition.<sup>16</sup>

In the past few years, Pt-based nanomaterials had caused widespread concern because they can provide a large number of active site locations on catalytic activity. A number of works had focused on modifying the shape and size. At present, various structures such as hollow spheres,<sup>17</sup> nanochains/wires,<sup>18</sup> nanobowls,<sup>19</sup> nanoparticles (NPs),<sup>20</sup> *etc.* have been synthesized. In order to enhance catalysis efficiency, great progress have been made by raising active surface area.<sup>21-25</sup> Recently, Pt-based nanomaterials have been confirmed to have high catalytic efficiency in various types of fuel cells, such as direct methanol fuel cells (DMFCs),<sup>26</sup> proton exchange membrane fuel cells (PEMFCs),<sup>27</sup> *etc.* However, only a few studies have been performed on RS so far. Here, we fabricated electrode/NPs/substrate structures by dropping Ni<sub>x</sub>-Pt<sub>(1-x)</sub> NPs on Nb-0.7 wt%-doped SrTiO<sub>3</sub> (NSTO). Different from the previous work,<sup>8,28-31</sup> the composition of Ni : Pt is tunable from 100 : 0 to 70 : 30. The prepared samples are annealed in different atmosphere. RS effects were found and the possible reasons of the existing phenomena have been discussed.

## Experimental section

Commercially available Ni(acac)<sub>2</sub> (nickel acetylacetonate), Pt(acac)<sub>2</sub> (platinum acetylacetonate) and C<sub>18</sub>H<sub>37</sub>N (oleylamine) were purchased from Chinese reagent companies. All reagents are of analytic grade and direct use without treatment.

In a typical process of synthesis, Ni(acac)<sub>2</sub> and Pt(acac)<sub>2</sub> was placed in 10 ml C<sub>18</sub>H<sub>37</sub>N at 300 K. The mixed solution was stirred for 15 min, then gradually heating up while stirring, to 130 °C in the argon. This stage of process was maintained for another 30 minutes in order the mixture to get stirred evenly. The solution

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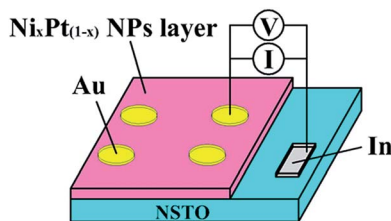
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† Electronic supplementary information (ESI) available: Fig. S1 *I*-*V* characteristics of Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs/NSTO/In devices. See DOI: 10.1039/c6ra24987f



Table 1 Qualities of the precursors for preparing  $\text{Ni}_x\text{Pt}_{(1-x)}$ 

Sample	A	B	C
$\text{Ni}(\text{acac})_2$	20 mg	25 mg	30 mg
$\text{Pt}(\text{acac})_2$	10 mg	5 mg	0 mg
Oleylamine	10 ml	10 ml	10 ml

Fig. 1 Schematic diagram of Au/ $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs/NSTO device.

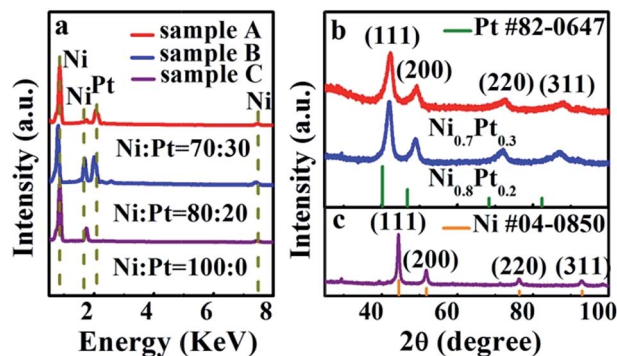
was further heated at 250 °C for 40 min in argon atmosphere. This gave rise to black precipitate by the formation of  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs. Then, this solution was naturally cooled to room temperature. The product was collected by centrifugation and washed several times with acetone and trichloromethane. The different contents of  $\text{Ni}_x\text{Pt}_{(1-x)}$  composites are listed in Table 1.

Accurate determination of the crystal structures and the material phase of the as-synthesized products were characterized by X-ray diffractometry (XRD; Ultima IV, Cu  $K\alpha$  radiation, 0.154 nm) in the angle range 0–90° was measured by laboratory methods in powder form. Energy dispersive X-ray spectroscope (EDS), transmission electron microscopy (TEM; JEOL 2200F) and high-resolution TEM (HRTEM) operated at 200 kV. TEM and HRTEM samples were prepared by dissolving the as-synthesized products in toluene with ultrasonic treatment, and then the well-dispersed solution was dropped on carbon-coated TEM grids and dried in air. X-ray photoelectron spectroscopy (XPS) was used in an ESCALab 250Xi system.

To fabricate the RS devices, before employment, we cleaned commercially available NSTO with alcohol for 20 min. The  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs layer of about 410 nm in thickness was deposited on the substrates by dip-coating, a film of Au about 60 nm in thickness was then deposited on the topmost by DC magnetron sputtering. The area of the Au was determined by a shadow mask of the  $\phi$  1.5 mm. Indium (In) was pasted in NSTO as the bottom electrode. Fig. 1 shows the device structure. Current–voltage ( $I$ – $V$ ) characteristics were performed with using an ampere meter (Keithley 2400), a pulsed voltage with an interval of 5 s and a width of 0.5 s was applied to measure the  $I$ – $V$  curves. The current from the positive to the substrate is defined as the positive current.

## Results and discussion

Fig. 2a exhibits the EDS spectrum of the as-synthesized material, which are prepared by different composition ratios of Ni : Pt in the source reaction mixtures. The atomic ratio of the synthesized product is obtained by EDS, including 70 : 30, 80 : 20 and 100 : 0. The powder XRD spectra of the as-prepared

Fig. 2 (a) EDS analysis reveals the atomic ratio of Ni and Pt. (b) XRD pattern of  $\text{Ni}_x\text{Pt}_{(1-x)}$ . (c) XRD pattern of Ni.

NPs are shown in Fig. 2b and c. In Fig. 2b, four peaks of two proportional alloys about in the position of 29, 42, 49 and 72° are recognized as (111), (200), (220) and (311) planes, respectively. It is reasonable to conclude that (1) the peak position of the  $\text{Ni}_x\text{Pt}_{(1-x)}$  alloy between the pure phase Pt and pure phase Ni and not are observed isolated Pt and Ni peaks, showing good crystal properties. (2) The peak position of the  $\text{Ni}_x\text{Pt}_{(1-x)}$  alloy had a certain offset compared with Pt peak, and the degree of migration increasing with the increase of Ni content, indicating a increase in the lattice constant caused by replacing the Pt atoms with Ni atoms. The pure Ni NPs are shown in Fig. 2c by contrast. Four peaks of 44.44, 51.76, 76.26 and 92.94° are corresponded with (111), (200), (220) and (311) planes, respectively. All of these  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs have a typical pattern of face-centered cubic (FCC) structure, in agreement with the TEM result (Fig. 3).

The morphology and size of  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs are observed by TEM at the same magnifications (Fig. 3a–c). Most of the as-prepared  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs are in irregular, close to spherical shape. The particle size distributions are about 20–30 nm for

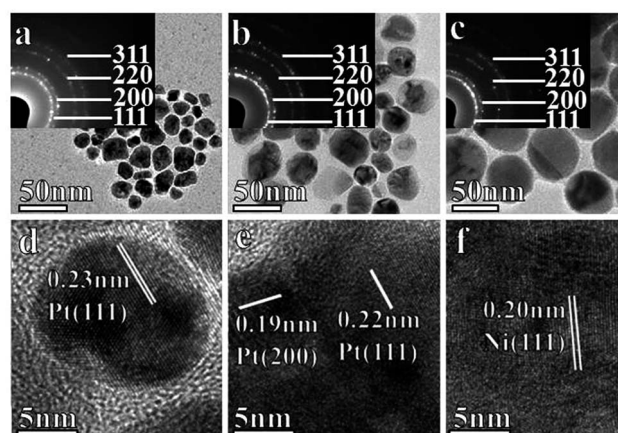


Fig. 3 TEM image of the  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs: (a) the size of  $\text{Ni}_{0.7}\text{Pt}_{0.3}$  is about 20–30 nm. (b) The size of  $\text{Ni}_{0.8}\text{Pt}_{0.2}$  is about 30–35 nm. (c) The size of Ni is about 45–50 nm. Typical HRTEM image: (d) single crystal  $\text{Ni}_{0.7}\text{Pt}_{0.3}$  NPs. (e) Single crystal  $\text{Ni}_{0.8}\text{Pt}_{0.2}$  NPs. (f) Single crystal Ni NPs. Inset of (a) is corresponding SAED pattern of  $\text{Ni}_{0.7}\text{Pt}_{0.3}$ . Inset of (b) is corresponding SAED pattern of  $\text{Ni}_{0.8}\text{Pt}_{0.2}$ . Inset of (c) is corresponding SAED pattern of Ni.



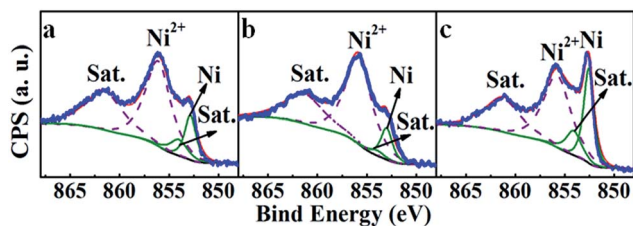


Fig. 4 XPS fitting analysis of the peak of Ni  $2p_{3/2}$   $Ni_xPt_{(1-x)}$  NPs deposited on the substrates. (a)  $Ni_{0.7}Pt_{0.3}$ . (b)  $Ni_{0.8}Pt_{0.2}$ . (c) Ni.

$Ni_{0.7}Pt_{0.3}$  in Fig. 3a, 30–35 nm  $Ni_{0.8}Pt_{0.2}$  in Fig. 3b, and 45–50 nm for Ni in Fig. 3c. The grain size seems to increase with the increasing Ni content. This is because in the reaction with more Ni, relatively higher monomer concentration will continue to grow after the nucleation. All of  $Ni_xPt_{(1-x)}$  NPs have apparently single crystal structures according to the HRTEM results in Fig. 3d–f. The lattice fringes with a  $d$ -spacing of 0.22 nm, 0.23 nm is consistent with the (111) planar distance of FCC crystalline Pt, 0.19 nm is consistent with the (200) planar distance of FCC crystalline Pt and the lattice fringes with a  $d$ -spacing of 0.20 nm consistent with the (111) planar distance of FCC crystalline Ni. To further confirm the crystallization, inset of Fig. 3a–c show selected area electron diffraction (SAED) patterns. The apparent concentric rings should correspond to the (111), (200) and (220) planes with the consistent in  $d$ -spacing respectively, in agreement with XRD results shown in Fig. 2b and c. And we calculated that lattice parameter is  $a_1 = 0.37 \pm 0.01$  nm (inset of Fig. 3a),  $a_2 = 0.36 \pm 0.01$  nm (inset of Fig. 3b), which lies between standard FCC of Ni (0.352 nm) and Pt (0.392 nm). The percentage of Ni atomic from the lattice parameter was estimated about  $70 \pm 3\%$ .

XPS measurements and analyses are conducted. Fig. 4a–c show the XPS curves for the NPs of  $Ni_{0.7}Pt_{0.3}$ ,  $Ni_{0.8}Pt_{0.2}$  and Ni, respectively. The fitting analyses reveal the peaks of Ni  $2p_{3/2}$  for metallic nickel,  $Ni^{2+}$  from NiO, and their accompanying satellite peaks.<sup>32–34</sup> The results of fitting analyses are listed in Table 2. It is noted that the oxidation peak of  $Ni_xPt_{(1-x)}$  NPs are significantly higher than that of pure Ni. This indicates that the surface Ni of the alloys is easier to be oxidized to  $Ni^{2+}$ , than the pure Ni is.

Fig. 5 partly demonstrates the asymmetrical  $I$ - $V$  curves of the Au/ $Ni_xPt_{(1-x)}$  NPs/NSTO/In devices with different content of Ni. The remaining compositions of the devices are shown in Fig. S1.† The applied bias voltage is sweeping cyclically as  $4 \rightarrow 0 \rightarrow -4 \rightarrow 0 \rightarrow 4$  V. In the negative voltage phase, the current is in the negative direction accordingly. And in Fig. 5, the data in the negatively biased voltage are presented by multiplying a minus

Table 2 The compositions of Ni  $2p_{3/2}$

Substance	Peak	$Ni_{0.7}Pt_{0.3}$ (eV)	$Ni_{0.8}Pt_{0.2}$ (eV)	Ni (eV)
Ni metal	Main	852.78	852.65	852.57
	Sat.	854.1	854.05	854.08
NiO	Main	856.07	855.77	855.75
	Sat.	861.28	861.43	861.27

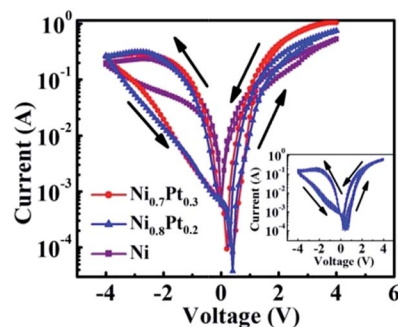


Fig. 5  $I$ - $V$  characteristics of the Au/ $Ni_xPt_{(1-x)}$  NPs/NSTO/In devices plotted in semilog scale. The inset is for the  $I$ - $V$  characteristics of the Au/ $Ni_{0.8}Pt_{0.2}$  NPs/NSTO/In device, taken by 50 times of continuous voltage sweeping measurements showing good stability.

sign. In the procedure of sweeping, positive bias switches the device into the LRS. Then, a subsequent reverse sweep made LRS switched to the HRS, showing obvious bipolar RS effect. Even though the applied bias disappears, the LRS or HRS still persists, exhibiting a memory property. There is a small  $R_{on}/R_{off}$  ratio (about 3.4) at  $-2.4$  V for Au/Ni NPs/NSTO. The ON/OFF ratio becomes even more pronounced with Au/ $Ni_xPt_{(1-x)}$  NPs/NSTO. Specifically, the  $R_{on}/R_{off}$  ratio is about 7.2 for Au/ $Ni_{0.7}Pt_{0.3}$  NPs/NSTO and 8.6 for Au/ $Ni_{0.8}Pt_{0.2}$  NPs/NSTO, at the same bias voltage of  $-2.4$  V. The enhancement of the ON/OFF ratio with the latter two devices might likely due to (1) the smaller size of  $Ni_xPt_{(1-x)}$  NPs which introduces more structure defects, leading to local enhancement of the leakage current, (2) electron transferring occurs with the formation of  $Ni_xPt_{(1-x)}$  alloy. By the alloying the electron distribution shifts away from Ni, making it more similar to a cation. The cation-like Ni in the surface is apt to react with oxygen, forming  $NiO_x$ . This is consistent with the XPS results in that the oxidation peaks of the  $Ni_xPt_{(1-x)}$  NPs are significantly higher than that of pure Ni in XPS analysis, discussed former in Fig. 4. Inset of Fig. 5 describes the Au/ $Ni_{0.8}Pt_{0.2}$  NPs/NSTO/In device 50 times of continuous circular sweep, showing cycling endurance of the RS characteristics.

The  $I$ - $V$  curve of the Au/ $Ni_{0.8}Pt_{0.2}$ /Au/NSTO device has been taken, shown in Fig. 6. The applied sweeping bias voltage is set in the cyclic order  $1.5 \rightarrow 0 \rightarrow -1.5 \rightarrow 0 \rightarrow 1.5$  V. The  $I$ - $V$  data are plotted in semilog scale, and also in the linear scale in the

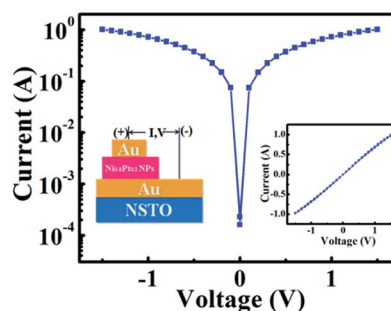


Fig. 6  $I$ - $V$  characteristics of the Au/ $Ni_{0.8}Pt_{0.2}$  NPs/Au/NSTO device plotted in semilog scale. A simple sketch for the device structure is provided, the inset is for the  $I$ - $V$  curve in linear scale.



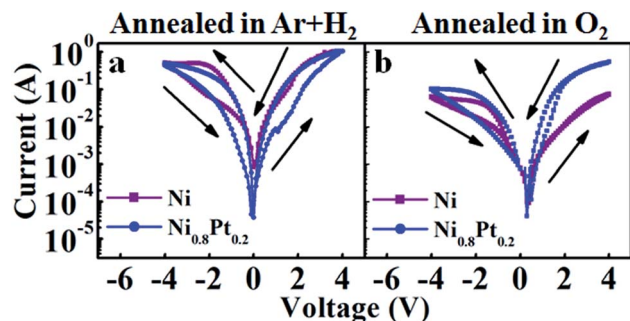


Fig. 7 The  $I$ - $V$  characteristics of Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs/NSTO/In devices annealed in different atmosphere. The  $I$ - $V$  curves for devices with Ni treated in the same conditions are also plotted as a reference. The bias voltage swept is 4 → 0 → -4 → 0 → 4 V. (a) Annealed in Ar + H<sub>2</sub>, (b) annealed in O<sub>2</sub>.

inset. It reveals obviously that the Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs junction is an ohmic contact, as well as the In/NSTO contact. In addition, there is no hysteresis observed. It demonstrates that the RS effects is irrelevant to the Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs interfaces.

The effects of annealing in the atmospheres of different gases on the  $I$ - $V$  properties are investigated for the devices with Ni<sub>0.8</sub>Pt<sub>0.2</sub> and Ni NPs. The annealing is taken places in the atmospheres of oxygen and argon-hydrogen mixture (5% hydrogen, 95% argon) at 500 °C for 30 min. The  $I$ - $V$  curves in semilog scale are shown in Fig. 7a and b for the argon-hydrogen and oxygen treatments, respectively. The magnitude of irreversibility with both cases of the  $I$ - $V$  hysteresis is suppressed perceptibly in comparison with the data without annealing shown in Fig. 5. This suggests that defects play an important role in the irreversible transport behavior. Another feature is further noted. In comparison to the data shown in Fig. 5, the resistance for Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO is smaller in Fig. 7a (annealed in argon-hydrogen), while larger in Fig. 7b (annealed in oxygen). When adding a positive bias on the Au electrode, electrons are released from the interface and the net plus charge produced lower the barrier height of the interface, which makes LRS. However, when adding a negative bias, the interface layer accumulates a large amount of electrons and produced higher barrier height of the interface, the device changed in the HRS.<sup>8,35,36</sup> Through controlling the annealing atmosphere, the concentration of Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs/NSTO oxygen vacancies can be tuned. Annealing in an oxidizing atmosphere, oxygen gradually diffuses into the Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs/NSTO depletion layer. The number of oxygen vacancies decreases with the increase of oxygen content in the depletion layer. On the other hand, annealing in the reducing atmosphere increases the concentration of Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO oxygen vacancies.<sup>37</sup> Therefore, annealing in an O<sub>2</sub> atmosphere will reduce the concentration of Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO oxygen vacancies so that the RS almost disappeared, but we can still see that the RS of the Ni<sub>x</sub>Pt<sub>(1-x)</sub> alloy is more obvious than that of the pure Ni; annealing in an argon-hydrogen atmosphere will increase the concentration of Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO oxygen vacancies so that the RS may increases.<sup>38</sup> However, due to the crystalline quality of the Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO becomes better and the defect decreases, the RS is reduced.

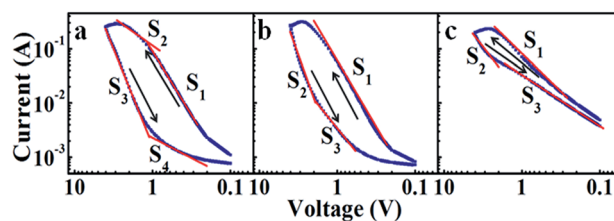


Fig. 8 The linear fitting of  $I$ - $V$  characteristic of Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs/NSTO at negative voltages: (a) Au/Ni<sub>0.7</sub>Pt<sub>0.3</sub> NPs/NSTO, slope<sub>1</sub> = 2.3, slope<sub>2</sub> = 1.1, slope<sub>3</sub> = 3.6, slope<sub>4</sub> = 1.2. (b) Au/Ni<sub>0.8</sub>Pt<sub>0.2</sub> NPs/NSTO, slope<sub>1</sub> = 2.2, slope<sub>2</sub> = 4.7, slope<sub>3</sub> = 2.0. (c) Au/Ni NPs/NSTO, slope<sub>1</sub> = 1.4, slope<sub>2</sub> = 2.4, slope<sub>3</sub> = 0.9.

In order to get a better explanation about the RS in different proportions Au/Ni<sub>x</sub>Pt<sub>(1-x)</sub>/NSTO memory devices,  $I$ - $V$  curves in Fig. 5 are repaint in a log-log scale. Fig. 8 clearly exhibits the different linear fitting results for the negative bias region using as-synthesized products at 300 K in bipolar memory switching for one switching cycle. It can be divided into three parts: two linear regions for smaller bias voltages and a nonlinear increase region for the between two smaller bias voltages. At low bias region, the curves have a linear region with a slope of  $\sim 1.0$  from 0–0.9 V for Fig. 8a, 0–1.5 V for Fig. 8c, indicating an ohmic conduction due to the ratio of  $\log(I)/\log(V)$  close to 1.0. This is because the thermally induced free carrier density dominates the conduction; the density of injected charge carriers is lower than that of thermally generated free carriers.<sup>39</sup> However, the slope of the corresponding curve for Ni<sub>0.8</sub>Pt<sub>0.2</sub> is 2.0, which could be easily classified in terms of the SCLC mechanism. It is followed by a large slope in region on the steep region characterized by: 1.0–3.9 V for Fig. 8a, 2.1–3.8 V for Fig. 8b and 2.2–4.0 V for Fig. 8c. In this bulk limited mechanism, the transport is corresponded to Child's law.<sup>40</sup>

$$I_{\text{SCL}} = \frac{9A\varepsilon_r\varepsilon_0\mu V^2}{8d^3} \quad (1)$$

where  $I$  is the current density,  $A$  is junction area,  $\varepsilon_r$  is the relative dielectric constant,  $\varepsilon_0$  is the permittivity of free space,  $\mu$  is the mobility of the charge carriers,  $V$  is the bias voltage and  $d$  is the film thickness. The slope of the typical  $\log(I)$ - $\log(V)$  curve is approximately equal to 2.0 for SCLC mechanism in high voltage region and the forming process above in the higher voltages basically matches the strong SCLC mechanism.<sup>41,42</sup> This indicates that within the measured voltage range the concentration of the injected free electrons greatly excess the equilibrium concentration in the intrinsic thermally generated carriers in Ni<sub>x</sub>Pt<sub>(1-x)</sub> NPs, dominate the transport.<sup>14</sup> The SCLC mechanism is widely reported in transition-metal oxides with high-density defects.<sup>43</sup> Moreover, it is found that there is a sharp current change with a slope of  $\sim 4$  in Fig. 8. The sharp change in the leakage current occurs at the so-called trap-filled-limit (TFL) voltage ( $V_{\text{TFL}}$ ), which can be expressed as:<sup>44</sup>

$$V_{\text{TFL}} = \frac{8qd^2N_t}{9\varepsilon_r\varepsilon_0} \quad (2)$$

where  $N_t$  is the trapped carrier density. After the traps are filled, the conduction recovers its trap-free characteristics. The trap-



related mechanism is consistent with the annealing result (Fig. 7): because annealing can effectively eliminate these traps, the RS characteristics are reduced in the annealed samples.

The overall RS mechanism of the  $\text{Ni}_x\text{Pt}_{(1-x)}/\text{NSTO}$  interfaces can be understood by considering the trapping/detrapping of charge carriers and the modulation of the depletion layer at the interface. Because the carrier concentration of  $\text{Ni}_x\text{Pt}_{(1-x)}$  is much higher than that of NSTO, the depletion layer is mainly at the  $\text{Ni}_x\text{Pt}_{(1-x)}$  side. Furthermore, positively charged oxygen vacancies and their complexes can serve as traps for charged carriers at the  $\text{Ni}_x\text{Pt}_{(1-x)}/\text{NSTO}$  interface. In the positive parts of the  $I$ - $V$  characteristics, lots of electrons flowing from the  $\text{Ni}_x\text{Pt}_{(1-x)}/\text{NSTO}$  interface get trapped, giving rise to a high leakage current at the high forward bias (LRS). Consequently, as the voltage sweeps to the negative side, the polarity of both voltage and current is reversed. When the Au electrode is negative biased, the positive charged oxygen vacancies are removed from the interface region; as a consequence, the defect density and the leakage current at the interface are reduced, and the device is reset to the HRS. In the transition from HRS to LRS, the steep current increase is a result of rapidly filled traps. The sweep of positive voltage moves the oxygen vacancies into the interface region, which leads to trapping-dominated transport and sets the device to LRS.<sup>40</sup> Our experiments suggest that the  $\text{Ni}_x\text{Pt}_{(1-x)}/\text{NSTO}$  heterostructure behaves as a switchable diode, which may present more functionalities in future studies. Furthermore, both the electronic SCL conduction and the ionic vacancy migration are indispensable ingredients in the data interpretation, producing complementary effects.

## Conclusions

In summary, we have prepared  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs and fabricated Au/ $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs/NSTO devices. The RS effects of the devices are compared with different Ni components in 300 K. The ON/OFF ratio of Au/ $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs/NSTO increases with the increasing the content of Ni, and the RS effect of the  $\text{Ni}_x\text{Pt}_{(1-x)}$  NPs is more obvious than that of the pure Ni. We cycled the Au/ $\text{Ni}_{0.8}\text{Pt}_{0.2}$  NPs/NSTO device 50 times, implying good endurance performance. By further fitting the  $I$ - $V$  curves, we prove that conduction mechanism is dominated by SCLC and TFL. Then we annealed the devices at 500 °C in different atmosphere, which make RS effect becoming smaller. Annealing in the atmosphere of oxygen triggers RS becomes smaller due to the depletion of oxygen vacancies in the layer. Whereas annealing in the atmosphere of argon-hydrogen made the RS becomes smaller, probably due to the improvement of crystalline quality and the decreasing of the defects at the  $\text{Ni}_x\text{Pt}_{(1-x)}/\text{NSTO}$  interfaces.

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